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14	9 A	6029141	02/22/00	Bezos et al.	705	27	06/27/97
M	$\frac{\mathcal{D}}{B}$	6055510	04/25/00	Henrick et al.	705	14	10/24/97
H	-	6154766	11/28/00	Yost et al.	709	201	06/30/99
H	D	6434544 B1	08/13/02	Bakalash et al.	707	2	02/28/00
H	E	6477536 B1	11/05/02	Pasumansky et al.	707	102	06/22/99
\vdash	F	6557008 B1	04/29/03	Temple, III et al.	707	104.1	12/07/99
	G	6574619 B1	06/03/03	Reddy et al.	707	2	03/24/00
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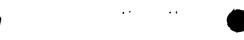
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A.	5787422	7/28/98	Tukey et al.	707	5	1/11/96	
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C.	6151601	11/21/00	Papierniak et al.	707	10	11/12/97	
D.	6233575	5/15/01	Agrawal et al.	707	6	6/23/98	
E.	6263334	7/17/01	Fayyad et al.	707	5	11/11/98	
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, G.	6567797	5/20/03	Schuetze et al.	707	2	10/19/99	
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1	E	6477536 B1	11/05/02	Pasumansky et al.	707	102	06/	22/99
1	F	6557008 B1	04/29/03	Temple, III et al.	707	104.1	12/07/99	
	G	6574619 B1	06/03/03	Reddy et al.	707	2	03/24/00	
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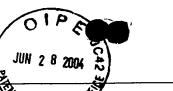
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Inf.	, A.	5809481	9/15/98	Baron et al.	705	14	8	/8/96
À	В.	5924068	7/13/99	Richard et al.	704	260	2	/4/97
	C.	5987247	11/16/99	Lau	395	702	5	/9/97
Н	D.	6026433	2/15/00	D'Arlach et al.	709	217	3/	17/97
H	E.	6029174	2/22/00	Sprenger et al.	707	103	10	/31/98
H	F.	6058398	5/2/00	Lee	707	104	5/	24/99
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H		6256623	7/3/01	Jones	707	3	6/	22/98
	н.	6289342	9/11/01	Lawrence et al.	707	7	5/	20/98
\downarrow	l	2002/0016735	2/7/02	Runge et al.	705	14		17/01
V	J.	6381599	4/30/02	Jones et al.	707	5		/15/99
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Application No. Applicant(s) 09/862,814 Seibel et al.

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PTO-1449

Docket Number Group Art Unit Docket Number 068082.0114 2177 068082.0114

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Ĺ	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A.	6401091	6/4/02	Butler et al.	707	10	12/5/95
В.	6430545	8/6/02	Honarvar et al.	706	47	12/21/98
C.	6434548	8/13/02	Emens et al.	707	3	12/7/99
D.	6438543	8/20/02	Kazi et al.	707	5	6/17/99
E.	6473756	10/29/02	Ballard	707	6	6/11/99
F.	6480842	11/12/02	Agassi et al.	707	4	3/25/99
G.	6555738	4/29/03	Hughes et al.	84	609	4/20/01
Н.	6567803	5/20/03	Ramasamy et al.	707	4	5/31/00
1.	6581054	6/17/03	Bogrett	707	4	7/30/99
J.	2003/0139975	7/24/03	Perkowski	705	26	12/12/02
<mark>/ к.</mark>	6625598	9/23/03	Kraffert	707	3	10/25/00
4 L.	6651065	11/18/03	Brown et al.	. 707	10	11/30/01

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U	Α.	6665658	12/16/03	DaCosta et al.	707	3	1/13/00	
1	В.	6677963	1/13/04	Mani et al.	345	764	11/16/99	_
7	C.	6684218	1/27/04	Santos et al.	707	102	11/21/00	
uk	D.	6684207	1/27/04	Greenfield et al.	707	3	8/1/01	
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